



In re Application of: Nakamoto et al.
Application No. 10/615,769
Filed: July 10, 2003
For: CHEMICAL PROCESSOR, CHEMICAL PROCESSING METHOD, AND METHOD
FOR MANUFACTURING SEMICONDUCTOR DEVICE

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

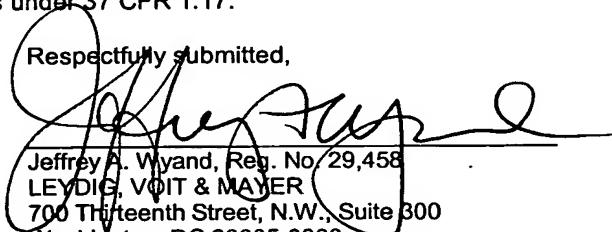
Sir:

- Small entity status is claimed for this application under 37 CFR 1.27.
- Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
- Other:
- Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

					SMALL ENTITY	OTHER THAN A SMALL ENTITY						
TIME EXTENSION PETITION FEE		none			\$ 0.00	\$ 0.00						
	subtract time extension fee previously paid	none			(\$ 0.00)	(\$ 0.00)						
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADDT. CLAIM FEE	RATE					
TOTAL	3	MINUS	20	=00	x 9=	\$	x 18=	\$				
INDEPENDENT	1	MINUS	3	=00	x 43=	\$	x 86=	\$				
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 145=	\$	+ 290=	\$				
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$0				

- The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.
- Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,


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Date:

April 20, 2004
Amendment or ROA Transmittal (Revised 10/2/03)



PATENT
Attorney Docket No. 402697/Takada

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

NAKAMOTO et al.

Application No. 10/615,769

Art Unit: 2818

Examiner: Phuc T. Dang

Filed: July 10, 2003

**For: CHEMICAL PROCESSOR,
CHEMICAL PROCESSING METHOD,
AND METHOD FOR
MANUFACTURING
SEMICONDUCTOR DEVICE**

RESPONSE TO OFFICE ACTION

**Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

Dear Sir:

In response to the Office Action dated March 31, 2004, please enter the following amendments and consider the following remarks.

In re Appln. of NAKAMOTO et al.
Application No. 10/615,769

TITLE AMENDMENTS

Replace the title with:
CHEMICAL PROCESSOR